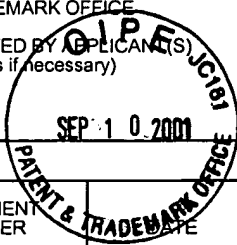



FORM PTO 1449 (modified) U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE LIST OF REFERENCES CITED BY APPLICANT(S) (Use several sheets if necessary)				ATTY DOCKET NO. 35.C15513		APPLICATION NO. 09/847,420	
				APPLICANT SHUJI YAMADA ET AL.			
				FILING DATE MAY 3, 2001		GROUP 2852	
U.S. PATENT DOCUMENTS							
*EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
ATP		6,208,071B1	03/27/01	Nishimura et al.			
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION YES/NO/ OR ABSTRACT
ATP		10-241550	09/11/98	Japan			Abstract and USP 6208071 B1
ATP		0850892A1	07/01/98	EPO			(In English)
OTHER DOCUMENT(S) (Including Author, Title, Date, Pertinent Pages, Etc.)							
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ATP		G. Dittmer, Thin Solid Films, 9, 317 (1972); Electrical Conduction and Electron Emission of Discontinuous Thin Films.					
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EXAMINER 				DATE CONSIDERED 4/7/03			

*EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.

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